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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Art Unit: 2815
Examiner: Richards

In re application of:
Gonzalez et al.

SEMICONDUCTOR RAISED
SOURCE-DRAIN STRUCTURE

Serial No.: 10/008,653

Filed: November 9, 2001

AMENDMENT AND RESPONSE TO OFFICE ACTION ACCOMPANYING REQUEST FOR
CONTINUED EXAMINATION UNDER 37 C.F.R. § 1.114

October 29, 2003

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Dear Commissioner:

INTRODUCTORY COMMENTS

In response to the office action dated July 29, 2003 with respect to the above-identified application ("subject application"), please amend the claims of the subject application as follows:

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TECHNOLOGY CENTER 2800